



OFFICIAL DOCKET NO. SC0192WD

RECEIVED
CENTRAL FAX CENTER

APR 28 2004

FAX TRANSMITTAL SHEET

Freescale Semiconductor, Inc.
Law Department
7700 W. Parmer Lane
MD: TX32/PL02
Austin, TX 78729
Telephone: (512) 996-6839
Facsimile: (512) 996-6854

6

Number of Pages (including this page)

Date: April 28, 2004
 To: Zoila E. Cabrera - 2125
 Location: United States Patent and Trademark Office
 Fax No.: (703) 872-9306
 From: Joanna G. Chiu - 43,629
 Subject: 09/729,636— Karl E. Mautz et al.

NOTICE: This facsimile transmission may contain information that is confidential, privileged, or exempt from disclosure under applicable law. It is intended only for the person to whom it is addressed. Unauthorized use, disclosure, copying or distribution may expose you to legal liability. If you have received this transmission in error, please immediately notify us by telephone (collect) to arrange for return of the documents received and any copies made. Thank you.

MESSAGE:

Enclosed herewith, please find a FORMAL AMENDMENT for filing in the below-identified application. If Applicant has overlooked any fees, or if any overpayment has been made, the Commissioner is hereby authorized to credit or debit Deposit 503079, Freescale Semiconductor, Inc.

ALL ITEMS MARKED WITH AN "X" ARE INCLUDED:
 1. 1 page Facsimile Cover Sheet
 2. 5 page Amendment

Paid by Deposit Account: 503079, Freescale Semiconductor, Inc. \$00

I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS
BEING FACSIMILE TRANSMITTED TO THE PATENT AND TRADEMARK OFFICE:

ON: 4-28-04
Date

Signature

PLEASE GIVE THESE PAPERS TO:

EXAMINER: Zoila E. Cabrera
 GROUP ART UNIT: 2125
 SERIAL NO.: 09/729,636
 FILED: DECEMBER 4, 2000
 INVENTOR: KARL E. MAUTZ ET AL.

RECEIVED
CENTRAL FAX CENTER

002/008

APR 28 2004

DOCKET NO. SC0192WD

UNITED STATES PATENT AND TRADEMARK OFFICE

OFFICIAL

APPLICANT(S) Karl E. Mautz et al.

GROUP ART UNIT: 2125

APPLN. NO.: 09/729,636

EXAMINER: Zoila E. Cabrera

FILED: December 4, 2000

TITLE: ASSEMBLY COMPRISING A PLURALITY OF MASK CONTAINERS
AMNUFACTURING SYSTEM FOR MANUFACTURING
SEMICONDUCTOR DEVICES AND METHODCertificate of Transmission under 37 CFR 1.8I hereby certify that this correspondence is being facsimile
transmitted to the Patcnt and Trademark Office.on 4-28-04_____
Pat Thomas S
SignaturePat Thomas
Printed Name of Person Signing CertificateRESPONSE TO REJECTION

Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

Sir:

Responsive to the Office Action dated January 29, 2004, and Examiner's comments with regard thereto, please enter the following amendments in the above-entitled application, without prejudice or disclaimer.